

Electronic Patent Application Fee Transmittal

Application Number:	10731651			
Filing Date:	09-Dec-2003			
Title of Invention:	VALVE CONTROL SYSTEM FOR ATOMIC LAYER DEPOSITION CHAMBER			
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Filer:	Robert W. Mulcahy/Sheri Griffin			
Attorney Docket Number:	5625 D01 USA			
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Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
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Utility Appl issue fee	1501	1	1400	1400
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Total in USD (\$)				1700